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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet

Complete if Known				
Application Number	10/608,855			
Filing Date	June 27, 2003			
First Named Inventor	Francesco CIOVACCO			
Group Art Unit	2811			
Examiner Name	Ori Naday			
Attorney Docket Number	2110-47-3			

		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	<u>-</u>
Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T2
0~		Hong Xiao, INTRODUCTION TO SEMICONDUCTOR MANUFACTURING TECHNOLOGY, pages 258-259, (Prentice-Hall, 2001)	
	·	CY Chang, SM Sze, ULSI technology (McGraw Hill, 1996)	<u> </u>
1	,	FF Chen, JP Chang, Principles of Plasma Processing (UCLA, 2002)	-
ON		http://www.lamrc.com/lech_1_1.cfm (hardcopy of this Web page is attached), TCP Design (2006)	

Examiner		Dete	
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